



#12 Election/A  
OSmails-2826  
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Attorney Docket SEU174

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Re Application of )  
)  
Yamazaki et al. )  
)  
Serial No.: 09/544,801 )  
)  
Filed: April 7, 2000 )  
)  
For: Semiconductor Device And )  
Method For Fabricating The Same )  
)  
Art Unit: 2826 )  
)  
Examiner: K. Quinto )

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: the Assistant Commissioner for Patents, Washington, D.C. 20231 on December 19, 2002  
(Date of Deposit)

Rachelle Hammerquist  
Name of applicant, assignee, or Registered Rep.  
12-19-02  
Signature Date

Commissioner for Patents  
Washington, D.C. 20231

December 19, 2002

**ELECTION AND AMENDMENT A**

Sir:

In response to the Restriction Requirement of November 19, 2002, Applicants elect to prosecute Group I: Claims 1-27.

Applicants are making this election without prejudice to later filing a divisional application on the non-elected claims.

Please also amend the above-identified application as follows:

**IN THE CLAIMS:**

Please amend the claims as follows:

A' 3.(Amended) A semiconductor device according to claim 1, wherein said first conductive layer comprises at least one selected from Ta, W, Ti and Mo, and said second conductive layer comprises Al or Cu.